

Notice of References Cited	Application/Control No. 10/045,112	Applicant(s)/Patent Under Reexamination BENANTAR, MESSAOUD	
	Examiner Shin-Hon Chen	Art Unit 2131	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,134,550	10-2000	Van Oorschot et al.	707/9
*	B	US-2002/0087859	07-2002	Weeks et al.	713/156
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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